

Notice of References Cited	Application/Control No. 10/791,786		Applicant(s)/Patent Under Reexamination ODA ET AL.	
	Examiner Timothy J. Henn		Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0080667	04-2004	Jeong et al.	348/374
*	B	US-7,283,854	10-2007	Sato et al.	455/575.3
	C	US-			
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	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	JP 2003051872 A	02-2003	Japan	IIDA, KENTARO	
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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